

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 1762
Examiner : J. Bell
Serial No. : 09/125,128
Filed : August 11, 1998
Inventors : Yuichiro Iguchi
: Masahiro Matsumoto
: Yuko Mikami
: Takaki Masaki
: Takao Sano
: Yoshiyuki Kitamura
: Toshinori Tani
: Hideki Ikeuchi
Title : A METHOD AND APPARATUS
: FOR PRODUCING A
: PLASMA DISPLAY

36th Floor
1600 Market Street
Philadelphia, PA 19103

Docket: 1084-98



RECEIVED
APR 12 2000
TC 1700 MAIL ROOM

Dated: April 5, 2000

AMENDMENT AND ARGUMENT

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

In response to the Official Action dated October 27, 1999, Applicants amend the application as follows:

In the Claims

Kindly amend the claims as follows:

33. (Amended) An apparatus for producing a plasma display, comprising a table for fixing a substrate with a plurality of barrier ribs formed on the surface, a paste applicator with a plurality of outlet holes to face the barrier ribs of the substrate wherein the average diameter (D) of the outlet holes of the paste applicator and the length (L) of each of the outlet holes satisfy the following relation:

$L/D = 0.1 \sim 600$; and

a supply means for supplying a phosphor paste to the paste applicator, and a moving means for three-dimensionally moving the table and the paste applicator relatively each other.